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DEC 26 2007

FAX TRANSMITTAL

DATE: December 26, 2007

TO: Examiner Thomas H. Stevens, United States Patent and Trademark Office

FAX PHONE NO: (571) 273-3715

FROM: Rodney C. Tullett

RE: In re Application of: Yuri Granik and Frank M. Schellenberg
Application No.: 09/898,431
Filed: July 2, 2001
For: METHOD OF COMPENSATING FOR ETCH EFFECTS IN
PHOTOLITHOGRAPHIC PROCESSING

OUR FILE: 1011-78093-02

NO. OF PAGES: 2 (including this cover page)

PLEASE ACKNOWLEDGE RECEIPT BY RETURN TELEPHONE CALL? ☒ Yes
☐ No

CONTACT INFO: If you do not receive all pages or if you have problems receiving transmittal, please call us at (206) 264-2960 as soon as possible and ask for Jessica Elaine Raucci.

MESSAGE:

Dear Examiner Stevens:

Please confirm the attached document is acceptable and confirm the Examiner Interview is scheduled as originally planned.

With best regards,

Jessica E. Raucci

Legal Assistant to Rodney C. Tullett

THE INFORMATION CONTAINED IN THIS TRANSMISSION IS CONFIDENTIAL AND ONLY FOR THE INTENDED RECIPIENT IDENTIFIED ABOVE. IF YOU ARE NOT THE INTENDED RECIPIENT, YOU ARE HEREBY NOTIFIED THAT ANY DISSEMINATION OR USE OF THIS COMMUNICATION IS UNLAWFUL. IF YOU HAVE RECEIVED THIS TRANSMISSION IN ERROR, PLEASE IMMEDIATELY NOTIFY US BY TELEPHONE (COLLECT), RETURN THE ORIGINAL MESSAGE TO US, AND RETAIN NO COPY.

Applicant Initiated Interview Request Form

Application No.: 09/898,431

Examiner: Thomas H. Stevens

First Named Applicant: Yuri Granik

Art Unit: 2121

Status of Application:

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Tentative Participants:

(1) Rodney Tullett

(2) Frank Schellenberg

(3)

(4)

Proposed Date of Interview:

Proposed Time: (AM/PM)

Type of Interview Requested:(1) ☒ Telephonic(2) ☐ Personal(3) ☐ Video ConferenceExhibit To Be Shown or Demonstrated: ☐ YES☐ NO

If yes, provide brief description:

Issues To Be Discussed

Issues (Rej., Obj., etc)	Claims/ Fig. #s	Prior Art	Discussed	Agreed	Not Agreed
(1) Rejection	1,5,8,12,23	Kim et al. 6,544,669		<input type="checkbox"/>	<input type="checkbox"/>
(2)			<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
(3)			<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
(4)			<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
<input type="checkbox"/> Continuation Sheet Attached					

Brief Description of Arguments to be Presented:

Kim et al. does not teach using results of an etch simulation to produce a revised set of mask/reticle data that is used as a target layer for OPC as set forth in Claim 1 or applying the etch biases calculated from an initial set of data within an OPC loop as in Claim 5.

An interview was conducted on the above-identified application on

NOTE: This form should be completed by applicant and submitted to the examiner in advance of the interview (see MPEP § 713.01).

This application will not be delayed from issue because of applicant's failure to submit a written record of this interview. Therefore, applicant is advised to file a statement of the substance of this interview (37 CFR 1.133(b)) as soon as possible.

Applicant/Applicant's Representative Signature

Examiner/SPE Signature

Rodney C. Tullett

Typed/Printed Name of Applicant or Representative

34,034

Registration Number, if applicable

This collection of information is required by 37 CFR 1.133. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.11 and 1.14. This collection is estimated to take 21 minutes to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.